

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: Yoshito Katano

Application 10/597,353

Group Art Unit: 2113

Filing date: July 6, 2007

Confirmation No. 9812

Customer No.: 26263

Examiner: Yolanda L. Wilson

For: **SEMICONDUCTOR DEVICE AND PROCESSING METHOD FOR  
STARTING THE SAME**

Electronically filed via EFS-Web  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

Sir:

In response to the Final Office Action of July 20, 2009, reconsideration of the application is requested in view of the remarks presented herein.